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**Product Name:**

Wafer total contain for cell washing sys 6640014919330 sterile 240s

**Special Features:**

For cell washing system 6640014919330 acp 215 automated cell processor; the copper wafer used by the total containment device (tcd) when it makes a sterile tubing connection; the wafer is equipped with and fds-mandated mylar seal which is designed to ensure the integrity of the sterile connection; the mylar seal is consumed once the tcd makes a connection, anew wafer must be used each time the tcd makes a sterile tubing connection

**Shelf Life:**

N/a

**Unit Of Measure:**

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**Demilitarization:**

No